

# Standard Operating Procedure

## Hitachi UHR CFE SU8230 SEM



Yale West Campus  
Materials Characterization Core  
[ywcmatsci.yale.edu](http://ywcmatsci.yale.edu)

ESC II, Room E119F  
810 West Campus Drive  
West Haven, CT 06516

Version 1.3, December 2016



- > Please ***FOLLOW the SOP strictly*** to keep the facility in good condition. Any ***explorations are strongly prohibited*** unless permitted by lab manager
- > ***NEVER*** use your own USB drive on the ***SEM computer***. Data can be retrieved from Yale data server
- > ***NEVER*** surf the web on the ***SEM/EDS computer*** in order to minimize the risk of the computer being hacked
  
- > Yale West Campus MCC facility users must acknowledge MCC in their publications that rely significantly on MCC resources. The general acknowledgement for SEM should read:  
“The micrographs were taken using the Hitachi SU8230 CFE SEM at Yale West Campus Materials Characterization Core (MCC).”
- > The core reserves the right to use the micrographs for core promotion



## Table of Contents

1	Introduction.....	1
2	Specimen Preparation .....	2
3	Starting Instrument.....	3
4	System Status Check.....	3
5	Loading the Specimen.....	5
6	Image Observation .....	9
7	Closing SEM measurement.....	15
8	Checklist after Experiment .....	16
9	Photodiode Back Scattered Electron (PD-BSE) detection.....	17
10	Scanning Transmission Electron Microscopy (STEM) detection .....	19
11	Energy Dispersive X-ray Spectroscopy (EDS).....	21



# Hitachi SU8230 Standard Operating Procedure

## 1 Introduction

### 1) Instrument features:

- > Cold field emission (**CFE**) e-beam source → high resolution on conductive surfaces (**0.8 nm** on Au clusters/magnetic tape)
- > Sliding-in annular Energy Dispersive Spectroscopy (**EDS**) detector → high elemental mapping resolution
- > Sliding-in annular Photo Diode **PD-BSE** detector → much high intensity backscattered electron detection than regular SE detectors
- > Scanning Transmission Electron Microscopy (**STEM**) detector → high resolution compositional contrast imaging, ideal for **EDS** mapping

### 2) Location

Materials Characterization Core  
Room E119  
810 West Campus Drive  
West Haven, CT 06516

### 3) Primary Staff Contact

Dr. Min Li  
Tel: 203-737-8270  
Email: min.li@yale.edu  
Office: ESC II, Room E119D

Zishan Wu, Lab Assistant  
zishan.wu@yale.edu  
203-824-5563 (cell)  
Office: ESC II

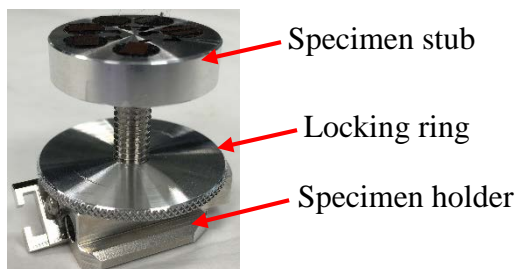
Yiren Zhong, Lab Assistant  
yiren.zhong@yale.edu  
203-710-9820 (cell)

The Yale West Campus MCC Facilities are operated for the benefit of all researchers. If you encounter any problems with this facility, please contact the staff member listed above immediately. There is never a penalty for asking questions. If the equipment is not behaving exactly the way it should, contact a staff member.

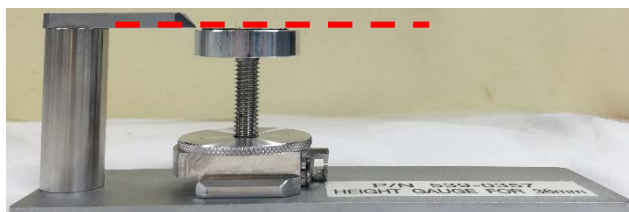
**Notice:** Please **follow** strictly the **SOP** to keep the facility under good condition. We **DO NOT** recommend user explorations on program unless endorsed by core manager.

## 2 Specimen Preparation<sup>1</sup>

- 1) **Always wear gloves** for vacuum sample preparation!! **Change gloves** if touched computer keyboard and mouse.
- 2) **The sample for SEM needs to be completely dried!**
  - a) The **powders samples** can be dripped and dried on Si substrate. Alternately, powders can be **sprinkled** on **Conducting Graphite Paint** (supplied in the Core) directly applied on the specimen stub, or on to double sided conducting carbon tab.  
**Note:** **Do not press the particles firmly** as it may change their surface morphology.  
**Note:** The **Conducting Graphite Paint** is highly recommended to fix the samples especially **magnetic** particles for **high magnification** (>100 k) measurement.  
**Warning:** use **maximal** pressure **dry N<sub>2</sub>** gas in the fume hood to **blow off loose particles** on powder samples before introduction into SEM chamber. **Loose particles will do damage to turbo pump in the specimen chamber (SC) and contaminate the vacuum including the lens system.**
  - b) The solid samples, large size flakes, single crystals can be fixed directly onto the sample holder using **Conducting Graphite Paint**.



- 3) Attach the specimen stub to the specimen holder; **DO NOT** overtighten the locking ring.
- 4) Adjust the height of specimen so that the **highest point on the sample** matches the **lower surface of the height gauge**.
  - a) **Caution:** if the paste at the edge of sample surpasses the sample surface, then align the paste to the height gauge.
  - b) **Warning: Failure** to follow the instruction may lead to severe damage to the lens system, and the **repair fee** will be charged to PI's account.)

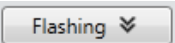


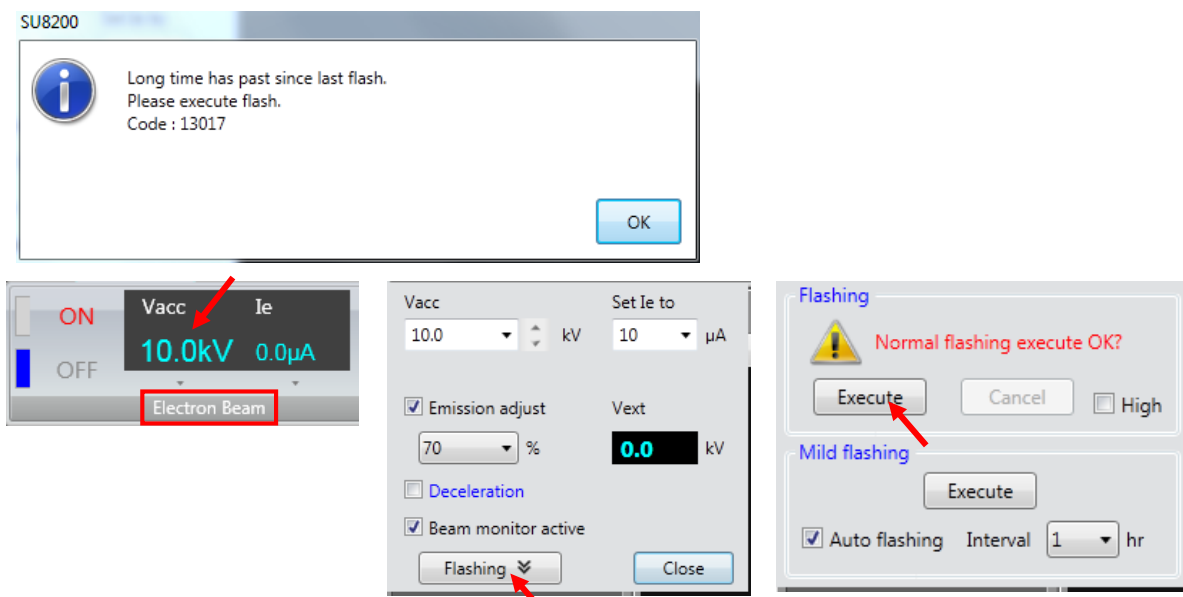
<sup>1</sup> **Always wear gloves** for your sample preparation in your own lab or in MCC! **Warnings** will be given for violations and the **user account will be revoked** after three warnings with notice to PI. Further training at PI's expense will be required to resume the account.



- 5) Bring the specimen stub inside the fume hood and blow off loose particles on the sample surface using the N<sub>2</sub> nozzle.<sup>2</sup>

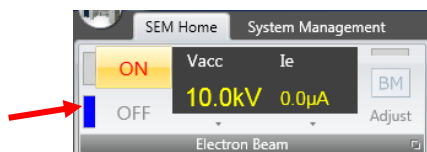
### 3 Starting Instrument

- 1) **Login** inside your reserved time box in **FOM calendar**.
- 2) **Sign in** on the **logbook** and put down **date**, **usage time**, **sample materials**, Specimen Chamber (**SC**) **pressure**, **imaging modes** (SEM, PD-BSE, STEM or EDS), and report any issues during measurement.
- 3) If the **PC\_SEM** program is not open, click **PC\_SEM** icon on desktop, choose or type **WC MCC** as profile name and hit **OK** button to login, no password required. (If the computer is logged off, then choose the profile **PC-SEM** and type **hitachi** to login.)
- 4) If a flashing message in yellow "**Execute Normal Flashing**" appears on top of the imaging window, click **OK** on the popup window, click the **Electron Beam** window and click  button to open the Flashing window. Make sure the **Vacc** is **OFF** (blue bar on), then click **Execute** button to flash the tip.



### 4 System Status Check

- 1) Check the **Electron Beam** window below: accelerating voltage **Vacc** should be **OFF** in the HV indication area with blue bar highlighted. If **Vacc** is **ON**, click the **OFF** button.

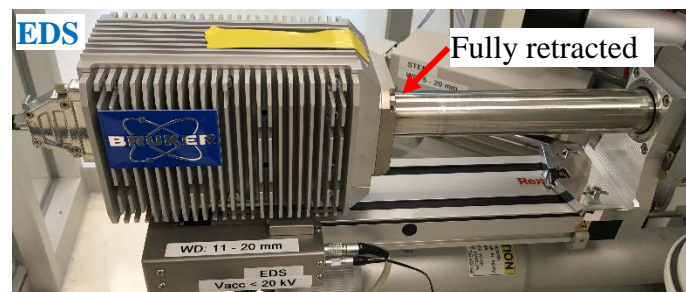
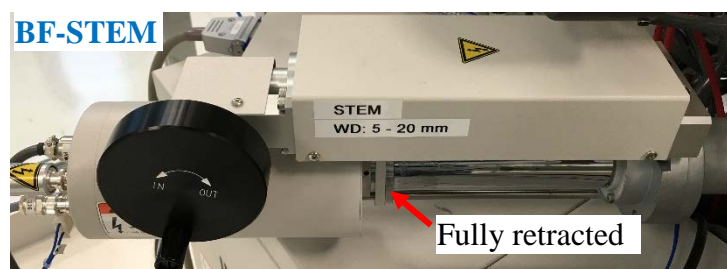
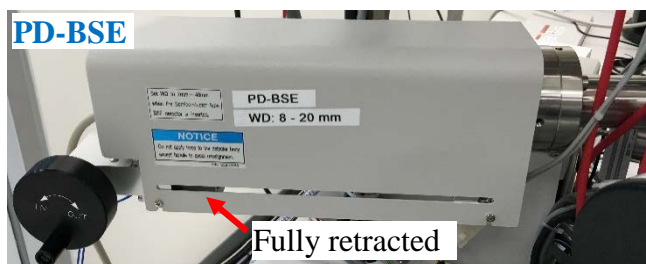


<sup>2</sup> **This step is crucial to keep the SEM chamber vacuum at good pressure**, which in turn improves the imaging resolution with less surface contamination and keeps the SEM lens system at good condition.

- 2) Turn on the Specimen Chamber **SC** chamber scope LCD (the switch is at the top left corner in the back)
  - a) **Caution:** the specimen holder should be empty and at the exchange **EXC** position
  - b) **Caution:** no other detectors (**PD-BSE** or **EDS**) underneath the pole piece.



- 3) Check if **PD-BSE**, **STEM** and **EDS** detectors are **fully retracted** outside the SEM chamber



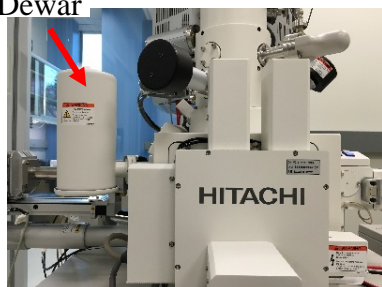
- 4) Check the Specimen Chamber **SC** pressure, which should read **LE-4 Pascal**. Fill the anti-contamination trap dewar with liquid nitrogen.<sup>3</sup>

<sup>3</sup> **Note:** this step is highly recommended for high magnifications **>100 k** or low accelerating voltages **< 1 kV**.



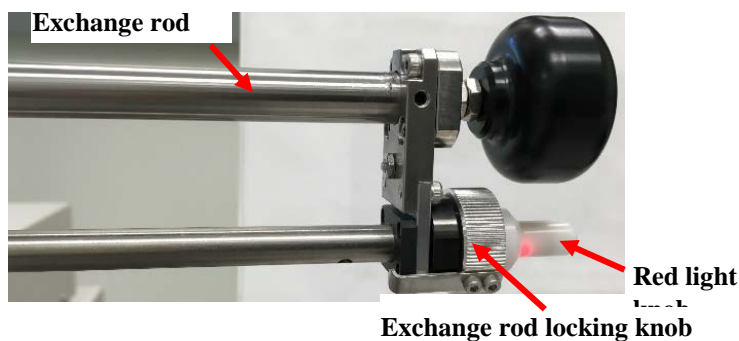
- 5) **Caution:** check the LN2 level momentarily during measurement to make sure the dewar is not **EMPTY**, otherwise the **quick outgassing** from the cold trap inside **SC** chamber will lead to pressure burst above  $10^{-3}$  Pa and **shutdown** the beam.

Dewar



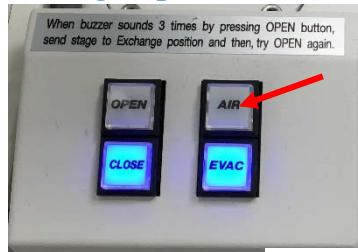
## 5 Loading the Specimen

- 1) Turn the **exchange rod locking** knob *clockwise* to lock the rod and make sure the **red light** on the locking knob is **ON**.



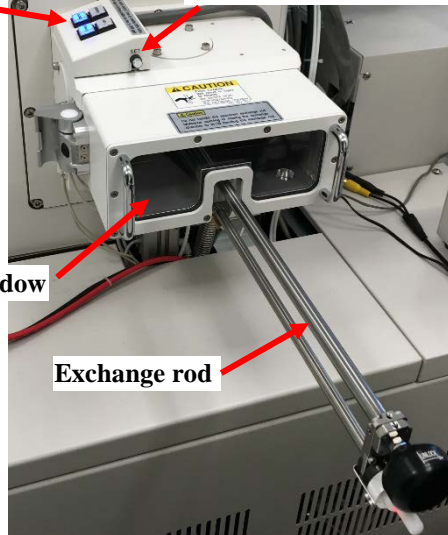
- 2) Press the **AIR** button on the **Exchange Operation Panel**. **Wait until** the buzzer sounds when air introduction into the specimen exchange chamber is complete.

## Exchange Operation Panel



Viewing window

Insertion detection lamp



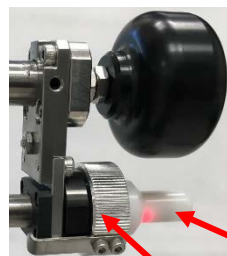
Exchange rod

- 3) **Push with your thumb** to open the exchange chamber door.

**Caution: DO NOT** hold the **exchange rod** to open the door, which will bend the rod with time and fail the sample transfer.



- 4) Insert the specimen stage onto the exchange rod  
 a) Turn the **exchange rod** locking knob **counterclockwise** to release the rod, and push the rod to see the fork.



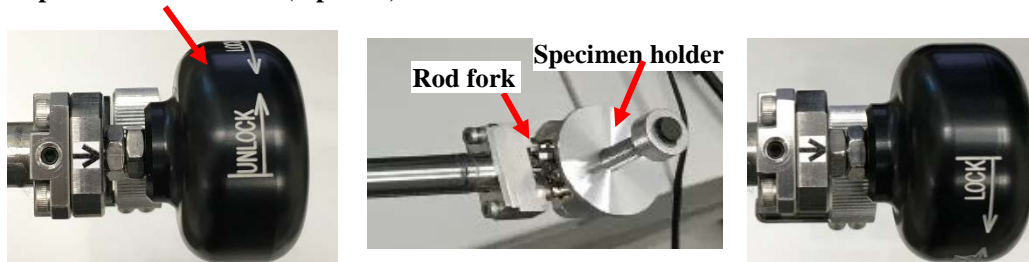
Red light  
 Exchange rod locking knob

Rod Fork



- b) Turn the specimen holder **lock/unlock** knob **clockwise** to the **unlock** position and insert the rod fork into the holes of the specimen holder. Turn the knob **counterclockwise** to the **lock** position and confirm that the holder is locked to the rod.

Specimen holder knob (top view)



**Warning:** it is crucial to **Make Sure** that the sample holder is at the **Lock** position for sample transfer. **Violation** will lead to transfer failure and parts damage on the SEM stage.

- 5) Pull the specimen **exchange rod** back into the airlock door and turn the exchange rod locking knob **clockwise** to **lock** the rod. The **red light** on the locking knob should be **ON**.



Red light

Exchange rod locking knob

- 6) **Hold and Press the exchange chamber** to close the door. Continue **holding** the specimen exchange chamber and pressing the **EVAC** button on the **exchange operation panel**. **Wait until** the buzzer sounds indicating the chamber is evacuated back into vacuum. **Caution: DO NOT** use the exchange rod to close the door as this will lead to rod bending with time.



Exchange Operation Panel



- 7) Press **OPEN** button on the exchange operation panel. **Wait until** the buzzer sounds and the gate valve is open.



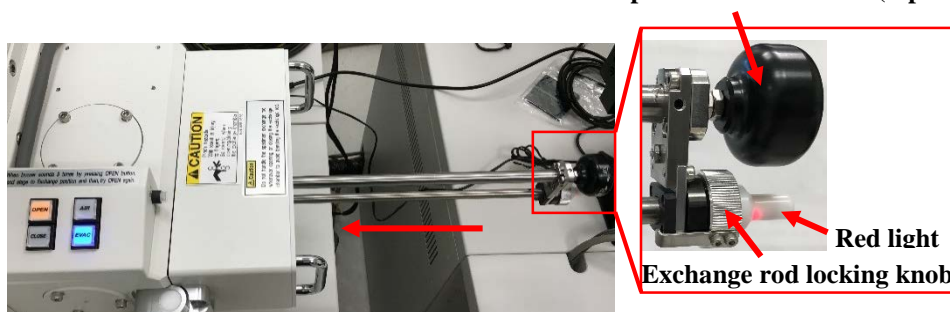


- 8) Turn the exchange rod locking knob *counterclockwise* to *release* the lock. Push the rod carefully into the **SC** chamber until the **insertion detection lamp** above the exchange chamber is lit in **blue**.

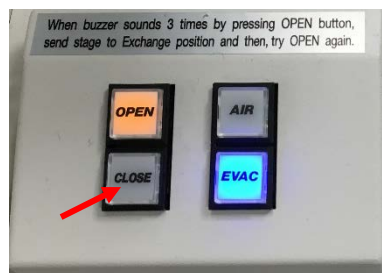
**Warning:**

- > **DO NOT** turn the **specimen holder knob** while pushing the rod into the **SC chamber**. This may cause accidental switch of **Lock** position to **Unlock** on the rod leading to sample transfer **failure** and mechanic **damage**.
- > **Always Hold and Push** the **knob** during transfer to prevent rod **accidental sliding** into **SC** due to pressure imbalance between exchange and SC chambers.

Specimen holder knob (top view)



- 9) Turn the **specimen holder lock/unlock knob** *clockwise* to **UNLOCK** position. Carefully retract the rod all the way to the back and turn **exchange rod locking knob** *clockwise* to lock the rod. The **red light** on the locking knob should be **ON**.
- 10) Press the **CLOSE** button on the exchange operation panel and wait until the buzzer sounds, indicating the sample transfer is complete.

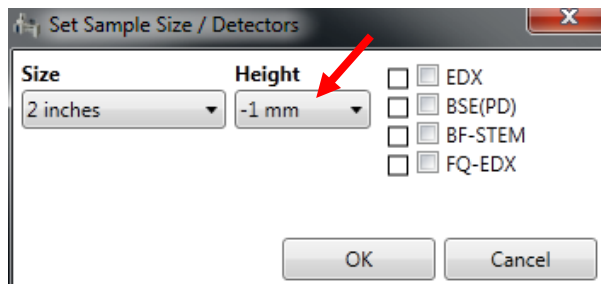
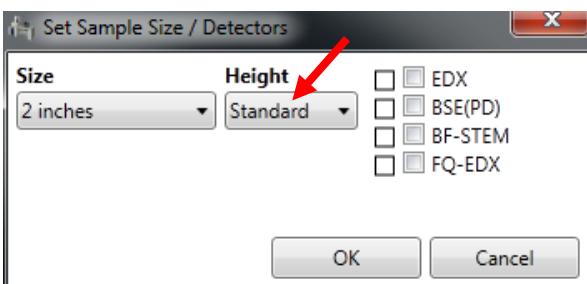


## 6 Image Observation

- 1) Click the **HOME** button on **PC-SEM** software top menu (**Caution: DO NOT** repeatedly click this button, which may lead to **STOP** button next ineffective). Use **SC** chamber scope LCD to see the sample holder moving from the exchange **EXC** position to **HOME** (measurement) position underneath the pole piece.

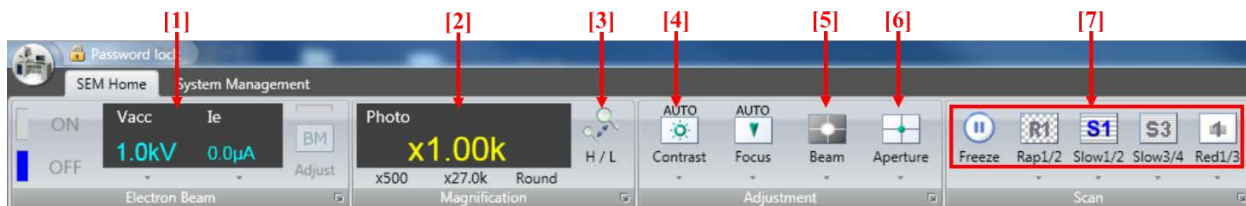


- 2) Click **Set** button in the **Stage** tab to set the specimen stub **Size** and **Height**
  - a) **Caution:** for **safety** purpose, always choose the specimen stub **one size** up, e.g.: choose **2 inches** for **1 inch** specimen stub).<sup>4)</sup>
  - b) For **Height** setting, **Standard** is recommended with carefully adjusted sample height using height gauge.  
**Warning:** If sample height is slightly low than the height gauge, e.g. 1 mm, then **-1 mm** should be chosen.
  - c) Check the boxes on right side if additional detectors will be in use. This will set up a safe **Z** movement range for detectors. To **AVOID damages to detectors**, please select **Z** within the range for different detection modes.



- 3) Confirm and set operating conditions.

<sup>4</sup> **Failure** to follow the instruction may lead to severe damage to the lens system; the user account will be revoked and the repair fee will be charged to PI's account.

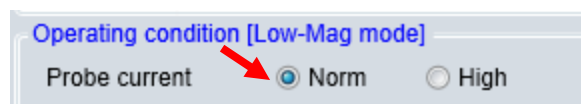


- a) [1] Choose accelerating voltage **Vacc** (typical values: **1kV**, **5 kV**, **10kV** or **15kV** for SEM imaging,

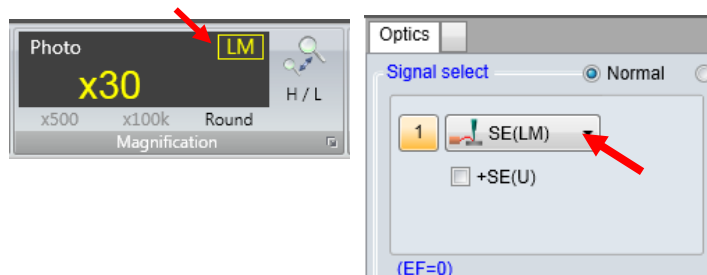
**Note:** always try small voltage first to avoid sample surface over-charging and **ebeam induced carbon deposition** (black imaging box)

**Caution:** **DO NOT** turn **Vacc ON** at this stage; and set the emission current **Ie** to **10  $\mu$ A**.

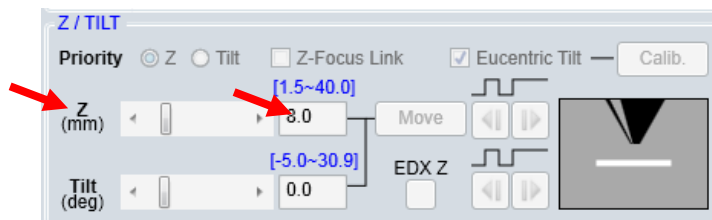
- b) Confirm the **Probe current** is checked at **Norm**.



- c) Click [3] **H / L** to choose **Lower Magnification** with **LM** appeared in window [2], and **make sure** that the **SE(LM)** detector appears in **Optics** tab



- d) Scan Mode: choose **Rapid Scan Mode** [7] to start with
- e) Set **Z height** (**Caution: the smallest Z height allowed is 5 mm**).<sup>5)</sup>



**Z height setting restrictions (Severe damage to lens may happen with  $z < 5$  mm):**

- Regular SEM: 5 – 20 mm**
- EDS: 11 – 20 mm**
- PD-BSE: 8 – 20 mm**
- BF-STEM: 5 – 20 mm**

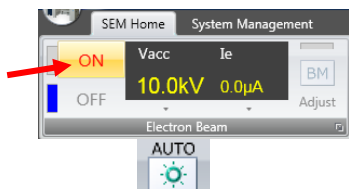
<sup>5</sup> **The Z height < 5mm** may lead to sample collision with lens. User's account will be suspended for damage caused by SOP violation and the repair expenses will be charged on user PI's account.



- 4) Check the Specimen Chamber (SC) pressure, which should read **LE-4 Pascal** on **EVAC CONTROL** panel.<sup>6</sup>



- 5) Click the **ON** button to turn on **Vacc** after **SC** pressure reaches **LE-4 Pascal**.



- 6) Click **[4]** Contrast on **PC\_SEM** window menu bar or **AUTO** button **[P-1]** on the **Manual Operation Panel** to adjust the image brightness/contrast. The **BRIGHTNESS** and **CONTRAST** knobs can be used separately to do manual adjustment.




**Manual Operation Panel**

- 7) Roll the track ball on the **STAGE CONTROLLER** to find the field of interest in LM mode:

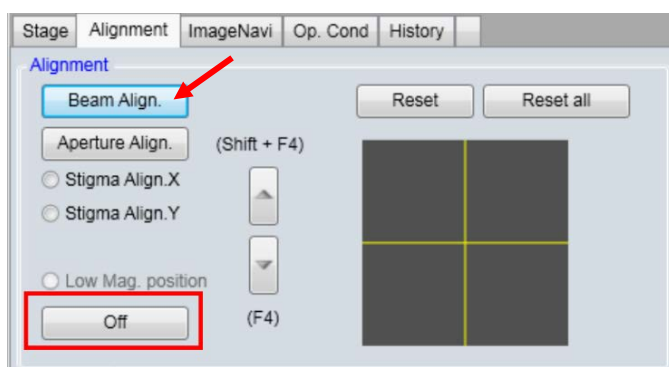


<sup>6</sup> **It is crucial to wait until the Specimen Chamber (SC) pressure is LE-4 Pa before turning on HV.** This usually takes up to **5 minutes** after sample transfer, and **2 minutes** with liquid nitrogen in the dewar. **Turning on HV in bad SC pressure** higher than LE-4 Pa will affect imaging resolution and shorten filament lifetime. Warnings will be given for violations and the user account will be revoked after three warnings with notice to PI. Further training at PI's expense will be required to resume the account.

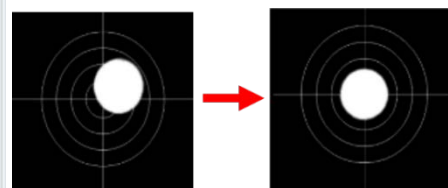
- a) Adjust magnification with the **MAGNIFICATION** knob [P-3] on the **Manual Operation Panel**.
  - b) Adjust focus using **FOCUS COARSE** and **FINE** knobs [P-4]. Move the stage to look for the field of interest in **LM** mode, and then click [3]  to switch to **High Magnification (HM)** mode.
- 8) In **HM** mode, change the magnification and adjust **FOCUS** knob on **Manual Operation Panel**

- a) If image **drifts** (swaying or heaving):
  - > Click **Alignment** tab and click **Beam Align** button. The **ALIGNMENT** LED on the **Manual Operation Panel** [P-2] should be **ON**. Bring the circular image to the center of the image area by adjusting **X** and **Y** knobs on [P-2], and then click the **Off** button on the **Alignment** tab to turn off the Alignment mode.




**Notice:** skip this step if **Vacc** is not changed



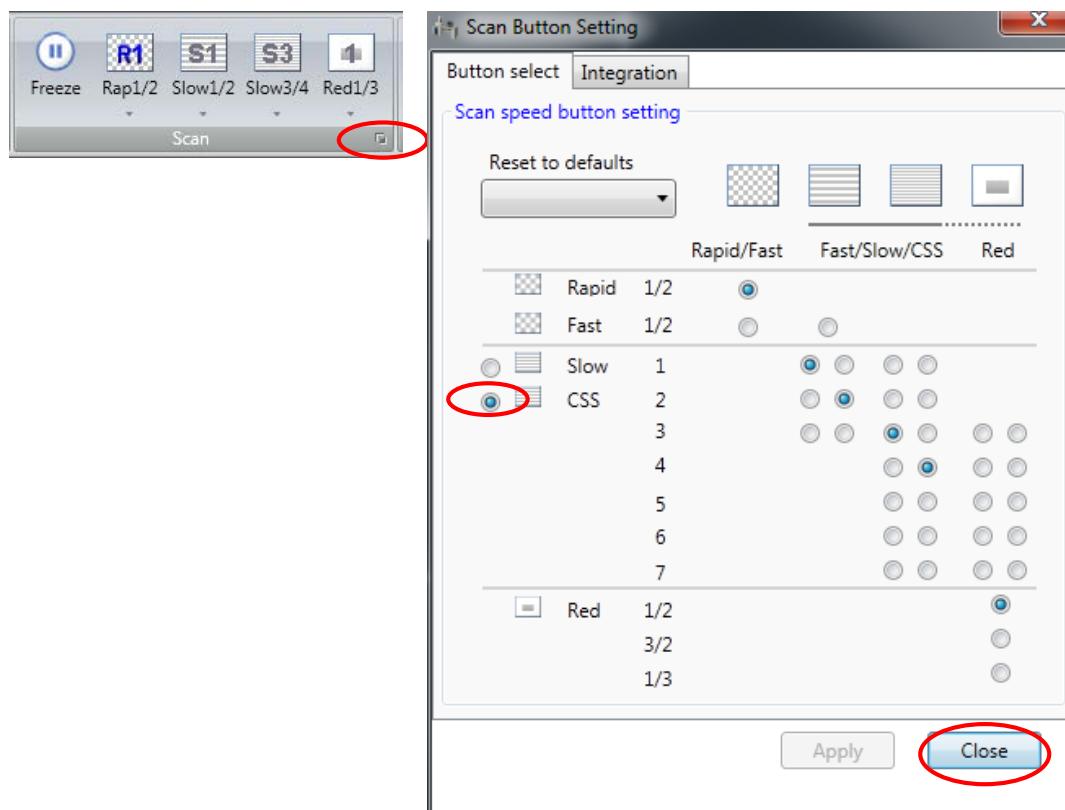
**Beam alignment**



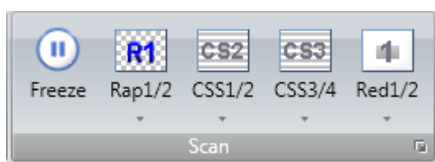
**Beam alignment image**

- > Click **Aperture Align** button below and adjust **STIGMA/ALIGNMENT X /Y** knobs [P-2] to minimize the wobbling motion in image
  - > Click **Stigma Align X/Y** button below and adjust **STIGMA/ALIGNMENT X /Y** knobs [P-2] to minimize the wobbling motion in image
  - > Click **Off** on **Alignment** tab
- b) If image **distorts** (stretching), correct **astigmatism**:
    - > Make sure the **Alignment** LED [P-2] is **OFF**, otherwise **Off** on **Alignment** tab
    - > Use the **STIGMA/ALIGNMENT X /Y** knobs [P-2] alternating with **FINE FOCUS** knob [P-4] to reduce distortion and obtain the sharpest image.
  - c) **Repeat** steps a) and b) at **each high magnification**
- 9) Select the field of view, confirm image with slow scan  Slow1/2 or  Slow3/4 and then, click the **Capture** button  Slow\_1280.
- 10) Image capturing settings for **charging samples**:
- > Choose **CSS** (Charge Suppressed Scan) mode:

- Clicking on the small box in the **Scan Menu** to open the Scan Button Setting window. Check the radio button next to CSS.
- Hit **Apply** button and **Close**.



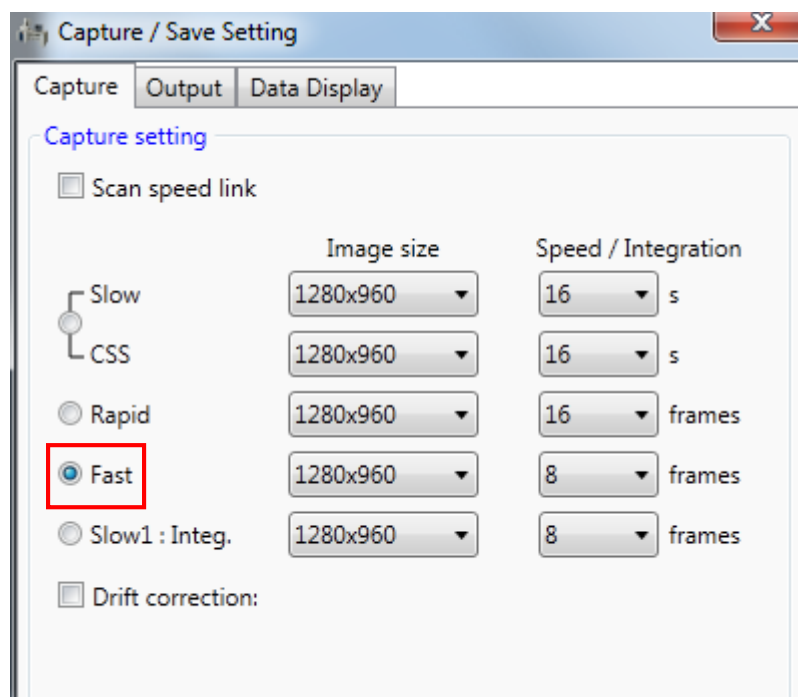
- The CSS Scan menu should appear as follows:



- If the charging is still strong on the surface, change the scan mode from line scan to frame mode:

> Click the small box by Capture menu to the Capture/Save Setting window. Choose **Fast** capture mode with 8 frames.

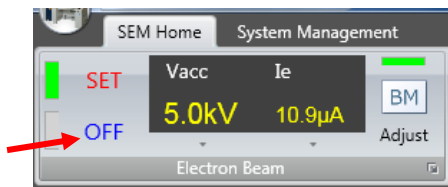




- 11) To save data, click **ALL** button on the bottom of the image thumbnail column and click **→PCI** button, the collected images will be transferred into the **Quartz PCI** program
- 12) In **Quartz PCI** program top menu bar, click **File** and select **Export All...** on the dropdown menu, then choose **export path** and **file format**.

## 7 Closing SEM measurement

- 1) Click the **OFF** button to turn off **Vacc**.



- 2) Fully **retract PD-BSE** or **EDS** detectors first if used.
- 3) Click the **EXC** button on **PC-SEM** software top menu to move the specimen stage to the exchange position.



- 4) To take out the specimen from the specimen chamber, follow the **reversed** order from sample insertion:
  - a) Press **OPEN** button on the exchange operation panel. **Wait until** the buzzer sounds and the gate valve is open.
  - b) Turn the **exchange rod locking knob** *counterclockwise* to **release** the lock. Push the rod carefully into the **SC** chamber until the **insertion detection lamp** above the exchange chamber is lit in **blue**.
  - c) Turn the **specimen holder lock/unlock knob** *counterclockwise* to **LOCK** position. Carefully pull out the rod all the way to touch the **exchange rod locking knob** and turn **exchange rod locking knob** *clockwise* to lock the rod. The **red light** on the locking knob should be **ON**.
  - d) Press the **CLOSE** button on the exchange operation panel and **wait until** the buzzer sounds, indicating the sample transfer is complete.
  - e) Press the **AIR** button on the **exchange operation panel**. **Wait until** the buzzer sounds when air introduction into the specimen exchange chamber is complete.
  - f) **Push with your thumb** at highlighted spot to open the exchange chamber door.
  - g) Turn the exchange rod locking knob *counterclockwise* to **release** the rod, and push the rod out of the open airlock door
  - h) Turn the specimen holder **lock/unlock** knob *clockwise* to **UNLOCK** position and remove the specimen stage from the exchange rod.
  - i) Pull the **specimen exchange rod** back into the airlock door and turn the **exchange rod locking knob** *clockwise* to lock the rod. The **red light** on the locking knob should be **ON**.
  - j) Press to close the specimen exchange chamber door, **hold the door and press** the **EVAC** button on the **exchange operation panel**. **Wait until** the buzzer sounds indicating the chamber is evacuated.
- 5) **Turn off** the SC **chamberscope LCD**.
- 6) **Leave the** **PC-SEM** program **ON**

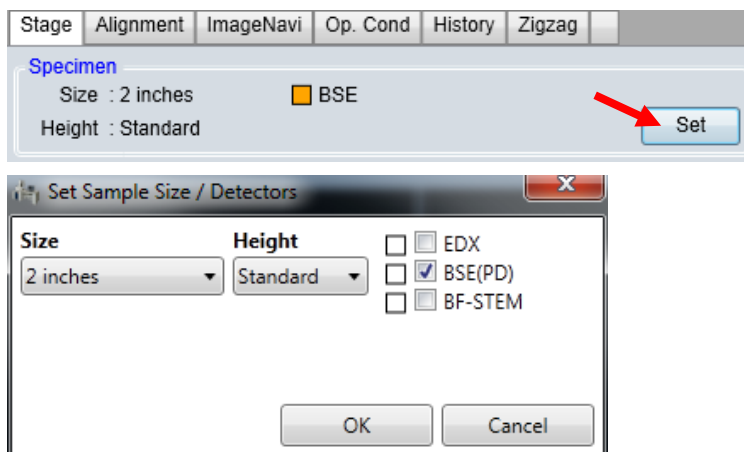
- 7) **Use ONLY** the core USB flash drive to transfer data from SEM computer to the workstation in the core, and then use either your own USB flash drive or internet to retrieve data.
- 8) **Log off** in your reserved time box in **FOM calendar** off the SEM monitor.

## 8 Checklist after Experiment

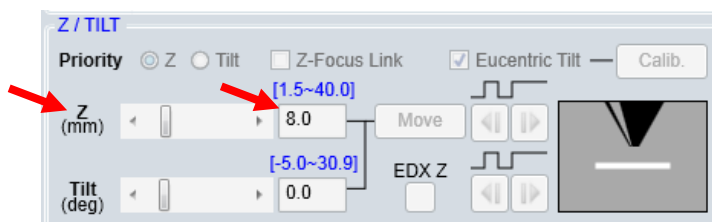
- 1) **Sign off** the **logbook** and report any problems.
- 2) **Remove** samples from the stub on the specimen holder, and **clean** the holder with Kimwipes using **Methanol/IPA**.
- 3) **Store** the specimen holder in assigned organizer box.
- 4) **Clear** the SEM work bench.

## 9 Photodiode Back Scattered Electron (PD-BSE) detection

- 1) Make sure **Vacc** is **OFF**
- 2) In **PC\_SEM** program with the sample holder at **EXC** or **HOME** position, click **Set** button in the **Stage** tab and check the **BSE** box



- 3) **To AVOID damages to detectors, choose Z range: 8-20 mm, typically 8 mm**



- 4) Select **Vacc  $\geq 15$  kV** and regular **Ie=10  $\mu$ A** as the **PD-BSE** requires high e-beam kV
- 5) Select **Dual Screen** mode on the **PC\_SEM** top menu bar, and choose **SE** detector for the first screen and **PD-BSE** detector the second






- 6) Switch to **LM** mode and turn **Vacc ON**
- 7) **Make sure the Z  $\geq 8$  mm**, crank (move) **slowly** the **PD-BSE detector** to the measurement position  
**Caution:** cranking slowly prevents the vibrations of detector and **SC** chamber, **stop** cranking once feel stopped
- 8) Monitor the movement of **PD-BSE** detector until it stops between sample and lens on chamber scope **LCD** screen and then **TURN OFF LCD** screen  
**Warning:** the **PD-BSE detector** is very **sensitive** to ambient light; the **LCD** screen must be **turned off** before PD-BSE imaging
- 9) Click **1** beside **SE** to activate **SE** imaging:

- a) Find interested areas on the sample inside the **annular PD-BSE** detector in **LM** mode; adjust focus and switch to **HM** mode.
- b) Get a **GOOD** image in **HM** mode


**Caution: Always** switch to **SE** window to adjust image quality for **PD-BSE** imaging

10) Click  beside  to activate **BSE** imaging:

- a) Click  or **AUTO** button on the **Manual Operation Panel** to adjust the image brightness/contrast. The **BIRGHTNESS** and **CONTRAST** knobs can be used separately to do manual adjustment

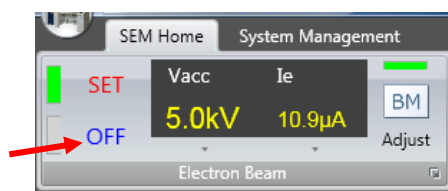
- b) Select the field of view, confirm image with slow scan  or  and then,

click the **Capture** button .

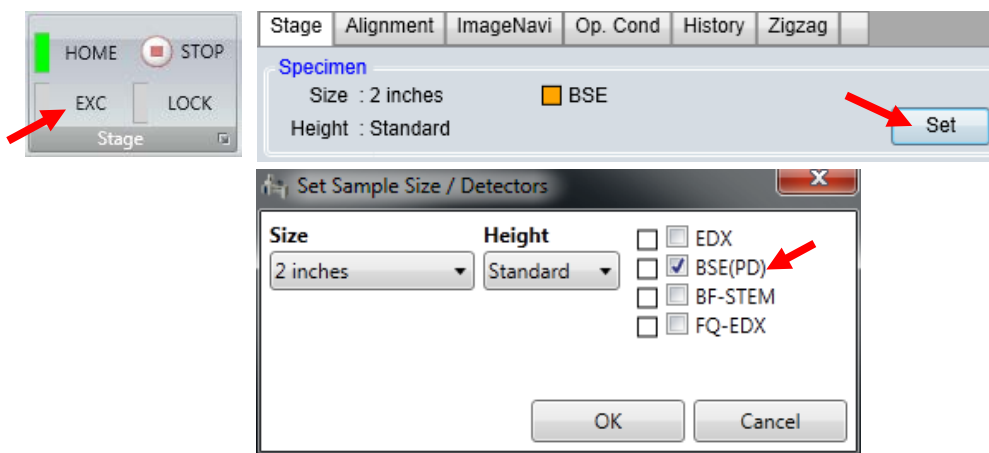
**Notice: do not** use  rapid scan mode for **PD-BSE** imaging

11) To quit **PD-BSE detection** mode:

- a) Switch to **LM** mode
- b) In **PC\_SEM** program, click the **OFF** button to turn off **Vacc**



- c) Turn the chamber scope **LCD ON**
- d) **Crank to fully retract the PD-BSE detector**
- e) Click the **EXC** button to move the specimen stage to the exchange position. Click **Set** button in the **Stage** tab; uncheck **BSE(PD)** box, and then following regular SEM instructions to take the sample out from chamber.

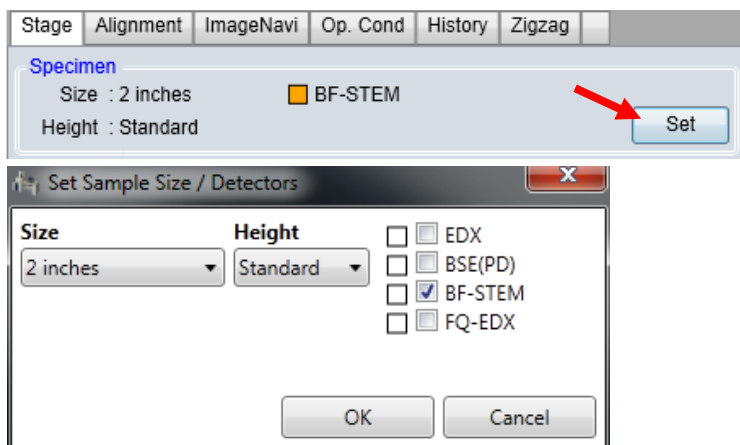




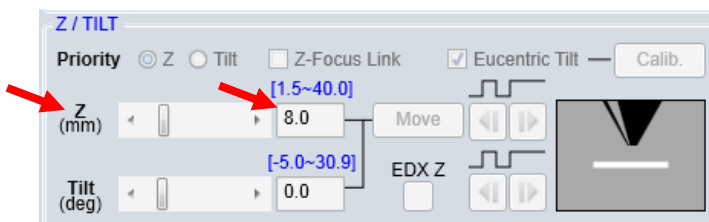
## 10 Scanning Transmission Electron Microscopy (STEM) detection

**Notice:** The STEM sample holder has standard **36 mm**, so **NO Height Gauge** is required.

- 1) Make sure **Vacc** is **OFF**
- 2) In **PC\_SEM** program with the sample holder at **EXC** or **HOME** position, click **Set** button in the **Stage** tab and check the **BF-STEM** (Bright Field) box









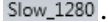

- 3) To **AVOID damages** to STEM detector, choose **Z range: 8-20 mm**, typically **8 mm** (especially if coupled with **EDS mapping** to avoid EDS detector damage)

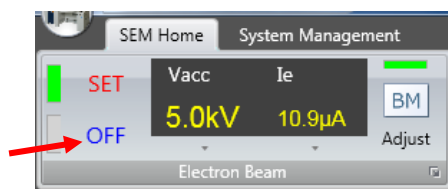


- 4) Select **Vacc ≤ 20 kV** and regular **Ie=10 μA** in **STEM** (especially if coupled with **EDS mapping** to avoid EDS detector damage)
- 5) Select **Dual Screen** mode on the **PC\_SEM** top menu bar, and choose **SE** detector for the first screen and **BF-STEM** detector the second



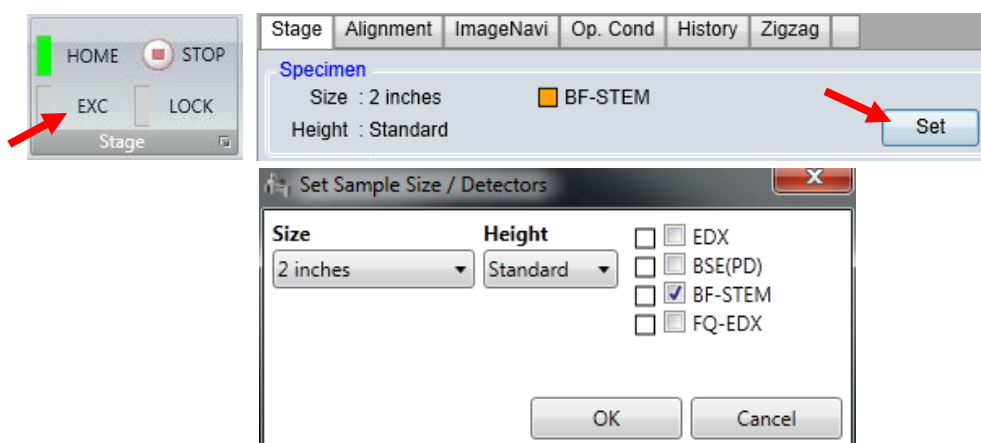
- 6) Switch to **LM** mode and turn **Vacc ON**
- 7) **Make sure the Z ≥ 8 mm**, **crank (move) slowly** the **STEM detector** to the measurement position  
**Caution:** **cranking slowly** prevents the vibrations of detector and **SC** chamber, **stop** cranking once feel stopped
- 8) Click **1** beside **SE** to activate **SE** imaging:

- a) Find interested areas on the sample in **LM** mode; adjust focus and switch to **HM** mode.
  - b) Get a **GOOD** image in **HM** mode  
**Caution: Always** switch to **SE** window to adjust image quality for **STEM** imaging
- 9) Click  beside  to activate **STEM** imaging:
- a) Click  or **AUTO** button on the **Manual Operation Panel** to adjust the image brightness/contrast. The **BIRGHTNESS** and **CONTRAST** knobs can be used separately to do manual adjustment
  - b) Select the field of view, confirm image with slow scan  or  and then, click the **Capture** button  .
- Notice: do not** use  rapid scan mode for **STEM** imaging
- 10) To quit **STEM detection** mode:
- a) In **PC\_SEM** program, click the **OFF** button to turn off **Vacc**, switch **Vacc** back to **15 kV**



**b) Crank to fully retract the STEM detector**

- c) Click the **EXC** button to move the specimen stage to the exchange position. Click **Set** button in the **Stage** tab; uncheck **BF-STEM** box, and then following regular SEM instructions to take the sample out from chamber.



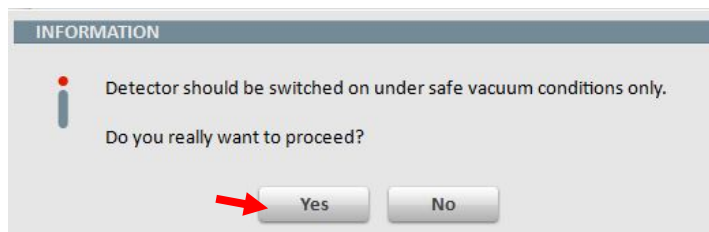
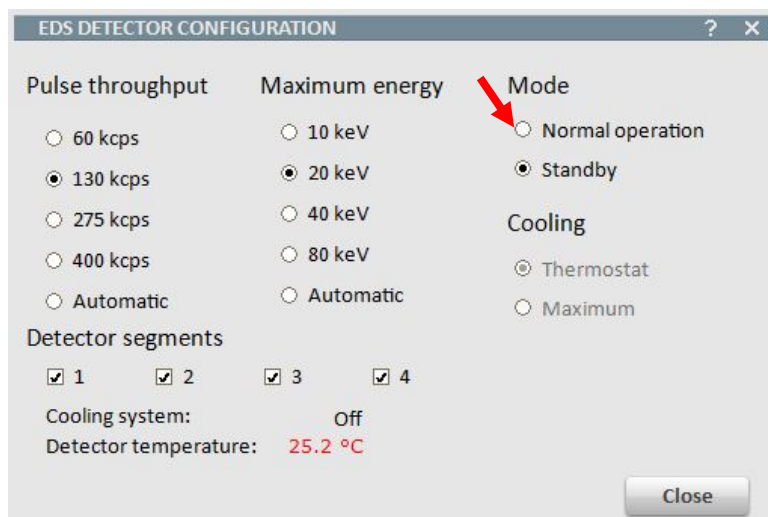
## 11 Energy Dispersive X-ray Spectroscopy (EDS)

Both regular **SE** sample holders and **STEM** holders can be used in **EDS** mode. We recommend samples mounted on **STEM** holder in **EDS mapping** for **good resolution**.

- 1) Make sure **Vacc** is **OFF**
- 2) On **PC\_SEM** top menu bar, **set Vacc up to 19 kV**

**Warning: It is extremely important to choose the **Vacc < 20 kV** in EDS mode. The EDS detector will be burned once exposed to high kV e-beam. The violation will lead to user account suspension and repair charge on user's PI account.**

- 3) Turn on **EDS** monitor and log into the profile **PC-SEM** with password **hitachi**
- 4) Turn on **EDS** detector in operation mode:
  - a) In **EDS Esprit** operating program, click the triangle in the **EDS** tab at the bottom left corner to open the **EDS DETECTOR CONFIGURATION** window, check **Normal operation**, read the **INFORMATION** window and hit **Yes** only if **SC** pressure is at **LE10-4 Pascal**. Close both **INFORMATION** and **EDS DETECTOR CONFIGURATION** window.

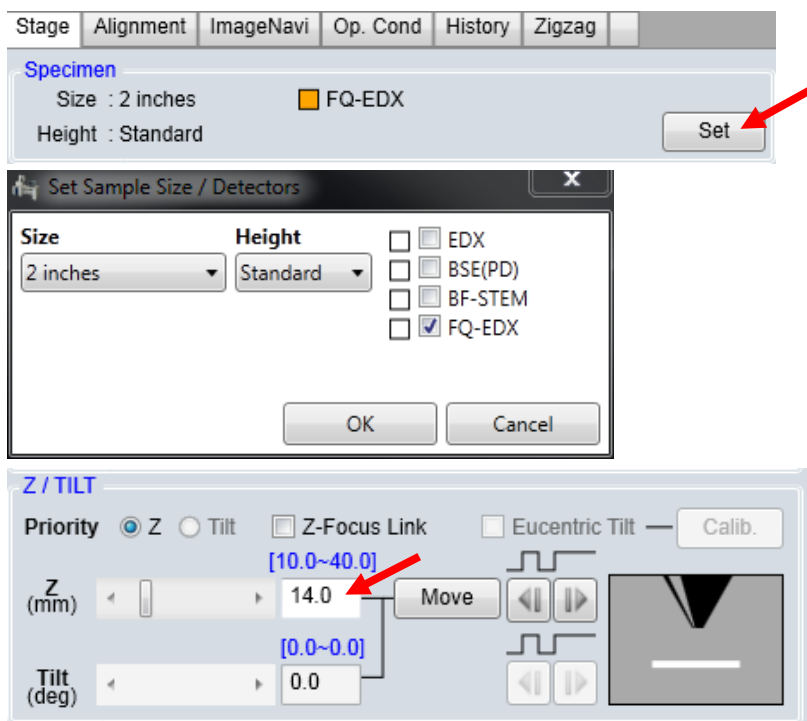



- b) Watch the **Temperature** reading drop to the operating temperature of **-20 °C**

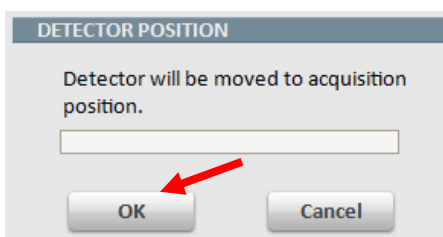


**Warning:** the EDS detector works only at **-20 °C** and it takes ~**5 minutes** to reach **-20 C**. **DO NOT** start **EDS** until the temperature of **-20 ± 0.5 °C** is shown.

- 5) In **PC\_SEM** program with the sample holder at **EXC** or **HOME** position, click **Set** button in the **Stage** tab and check the **FQ-EDX** box. The stage **Z position** should move to **14 mm**. **Warning: DO NOT** change the **Z position** < **11 mm**. This will lead to the **EDS detector** damage **hit** by the sample. This **severe SOP violation** will lead to user account suspension and charge on PI's account.



- 6) Switch to **EDS Esprit** program and click  button; click **OK** on **DETECTOR POSITION** window to move the detector to the acquisition position  
**Warning:** the **High Magnification** mode in **PC\_SEM** should be activated and **WD** should be set larger than **11 mm** before **EDS** detector can be moved.



- 7) Switch to **PC\_SEM** program, **make sure the V<sub>acc</sub> is set below 20 eV**
- Switch **V<sub>acc</sub>** **ON** and change the emission current **I<sub>e</sub>** to **30  $\mu$ A**
  - Change the **Probe current** to **High**.



- Choose either **SE** or **STEM** (if STEM holder is being used) detector
- Select interested area, adjust image quality (focus, stigma) and start SEM scan on

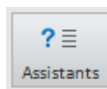


### Rapid Scan Mode

- 8) **Turn off** the chamberscope from the back of the monitor.
- Note:** This step is crucial, or **the EDS detector will be flooded by ambient signals** leading to fat peaks in spectra.

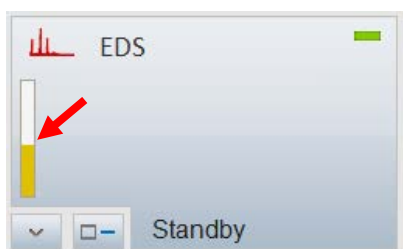
### 9) EDS scan

Switch to **EDS Esprit** program and select interested scan modes (**Spectra**, **Object**, **Line**



scan and **Mapping**). **Always click** **Assistants** for detailed instruction


**Note:** Before EDS spectral or mapping scan, **check the X-ray signal level** and make sure it is **near the middle of the bar** for good spectral resolution. Adjust the emission current if necessary to tune the signal into the right range.



- a) **Spectrum Acquisition Mode:**


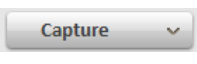


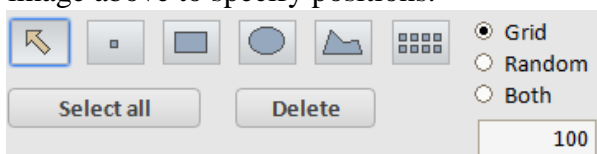
- > Click **Spectra** on the left side menu to enter **Spectra** workspace
- > Click **Preview** button to acquire live spectrum and hit **Preview** again to stop preview
- > Click **Acquire** button to start spectral scan

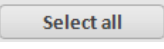
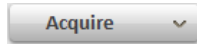

- > To add collected spectra into **project** or **report**, hit the  button on the top right corner of the spectral workspace
- > To save the data in Bruker spectra format (\*.spx) or export to \*.txt or \*.xlsx


format, click the lower  button.

b) **Objects Mode** (spectrum acquisition from objects in image):


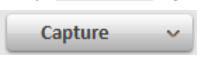

- > Hit  on the left side menu to enter **Object** workspace and hit  button to capture an image.
- > Select the desired object type on the bottom menu bar and click on captured image above to specify positions.

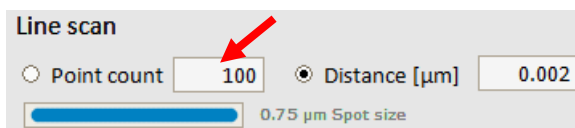


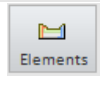

- > Click  to highlight all objects and click .
- > To save object data, click the  button on the top right corner of the workspace window.


- > To save the spectrum, click the lower spectrum chart .

c) **Line Scan Mode**:


- > Hit  on the left side menu to enter **Line Scan** workspace and hit  button to capture an image.
- > Highlight the line and drag and adjust the endpoints to the desired position
- > Set **Point count** of the line scan and click .

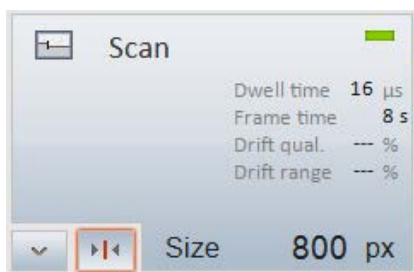



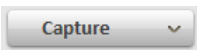
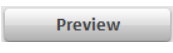
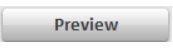

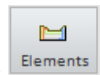
- > Use the  icon to identify elements
- > To save line scan data, click the  button on the top right corner of the workspace window.


- > To save the profile, click the lower profile chart .


d) **Mapping Mode**:


- > Click  button on **Scan** tab to activate image drift correction. Make sure the button is highlighted in **red**.



- > Hit  on the left side menu to enter **Mapping** workspace and hit  button to capture an image.
- > Click  button and adjust image; hit  again to stop preview
- > Click  button to start **Mapping**
- > Use the  icon to identify elements

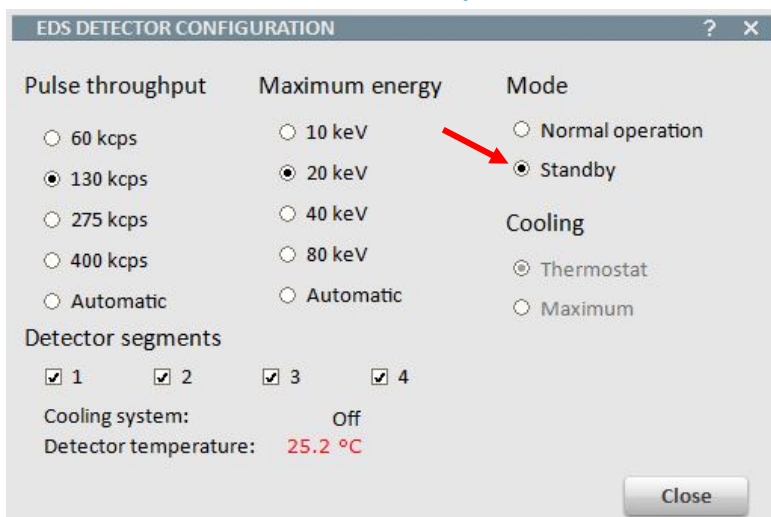
- > To save map data, click the  button on the top right corner of the workspace window.

- > To save the map image, click the lower image window .

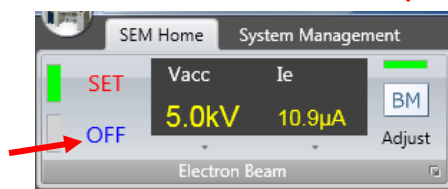
- > To save individual element image in the thumbnail on the bottom, click the thumbnail bar .

10) To quit **EDS detection** mode:

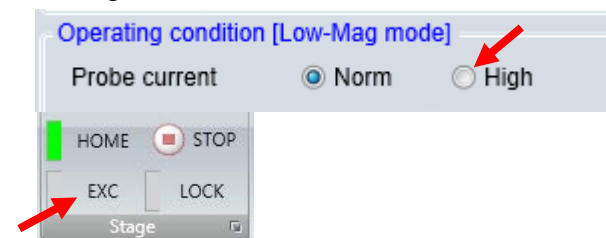
- a) Click **Standby** button in **EDS DETECTOR CONFIGURATION** window to switch the EDS detector to **Standby Mode**



- b) **Fully retract EDS detector** by clicking  in **EDS Esprit** program
- c) In **PC\_SEM** program, click the **OFF** button to **turn off Vacc**, change **Vacc** back to **10 kV** and the **Ie** back to **10  $\mu$ A**



- d) Change the **Probe current** back to **Norm.**



- e) In **PC\_SEM** program, click the **EXC** button to move the specimen stage to the exchange position.



- f) Click **Set** button in the **Stage** tab; uncheck **EDX** box, and then following regular SEM instructions to take the sample out from chamber.
- g) Keep **Esprit** program **ON** and just **close EDS** monitor!

